

**SEMI F72-0214**

**Test Method for Auger Electron Spectroscopy (AES) Evaluation of Oxide Layer of Wetted Surfaces of Passivated 316L Stainless Steel Components**

## **Test Report**

**Applicant Name: Linlin Xie**

**Product Name: 316L stainless steel products**



**BEIJING JU RUI ZHONG BANG HT-TECH CO.LTD**

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11月11日  
11月11日

# Test Report

**Applicant Name:** Linlin Xie

**Applicant Address:** No.1261, Enterprise Development Service Center,  
Xiji Town, Tongzhou District, Beijing

**Manufacturer:** Precess (Beijing)Semiconductor Co.,Ltd.

**Product description:** 316L stainless steel products

**Product Number:** 1

**Trademark:** /

**Report Number:** MG20241230-25596-2

**Date of Issue:** 2024.12.31

**Evaluated by:**

**Reviewed by:**



Xuhao Jiang

signature

2024.12.31

date

Li Xiaojing

signature

2024.12.31

date

**BEIJING JU RUI ZHONG BANG HT-TECH CO.LTD**

signature

date



- 2.3.2 Acquire a depth composition profile by ion etching to determine the relative abundance of carbon, oxygen, chromium, iron and nickel.
- 2.3.3 An initial survey spectrum extending from approximately 0 to 2000 eV.
- 2.3.4 A depth composition profile plot including Cr,Fe,Ni,O,C as a function of sputtering depth.
- 2.3.5 A table of the as-received surface elemental composition calculated from the initial survey spectrum.
- 2.3.6 A table of the oxide thickness, the carbon thickness, the chromium enriched layer thickness, the maximum of Cr/Fe ratio, the Cr/Fe ratio at 10Å, and the presence and thickness of the iron enriched oxide layer calculated from depth composition profile.

## 2.4 Acquisition parameters

Incident electron beam energy: 5KeV

Incident electron beam current: 10nA

Incident electron beam spot size: 20nm

Ion beam energy: 2KeV

Ion beam sputtering area: 2×2mm

SiO<sub>2</sub> etching rate: 5.2nm/min

The angle of the incident electron beam to the sample plane: 60°

Sample stage tilt angle: 30°

Scan area: 50×50μm

Vacuum: <math>1.2 \times 10^{-6}</math> Torr

Sample preparation: by the manufacturer

Analyst: mige02

Analysis date:2024.12.29

## 3. Test Result

### 3.1 Tabular summary of surface elemental composition

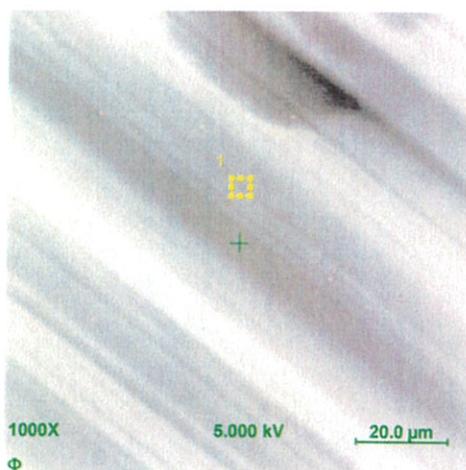
element	Atomic ratio	
	*	**
(C)	42.4	42.3
(Cr)	1.0	1.0
(Fe)	14.8	14.8
(Ni)	1.9	1.9
(O)	35.0	34.9
(Mo)	1.9	1.9
(S)	0.3	0.3
(P)	0.3	0.3
(N)	1.0	1.0
(Si)	1.4	~~
(Si(O))	~~	1.6
pollutant***	C, Si, N, S, P	

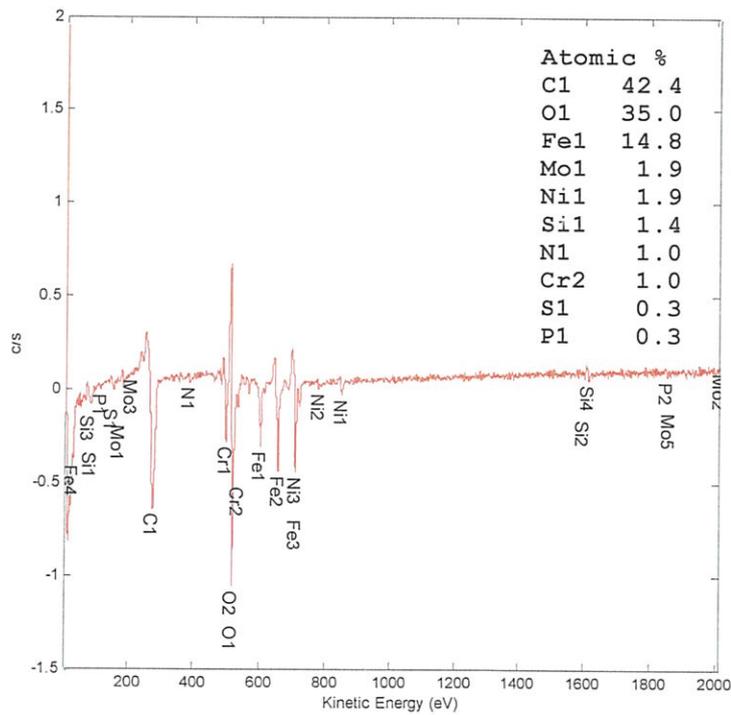
\* : The calculated percentage of Si is assumed to exist in the elemental state.

\*\* : The calculated percentage of Si is assumed to be in the form of an oxide.

\*\*\* : Only elements with concentrations greater than 0.2% of atoms are listed.

### 3.2 Elemental survey spectrum





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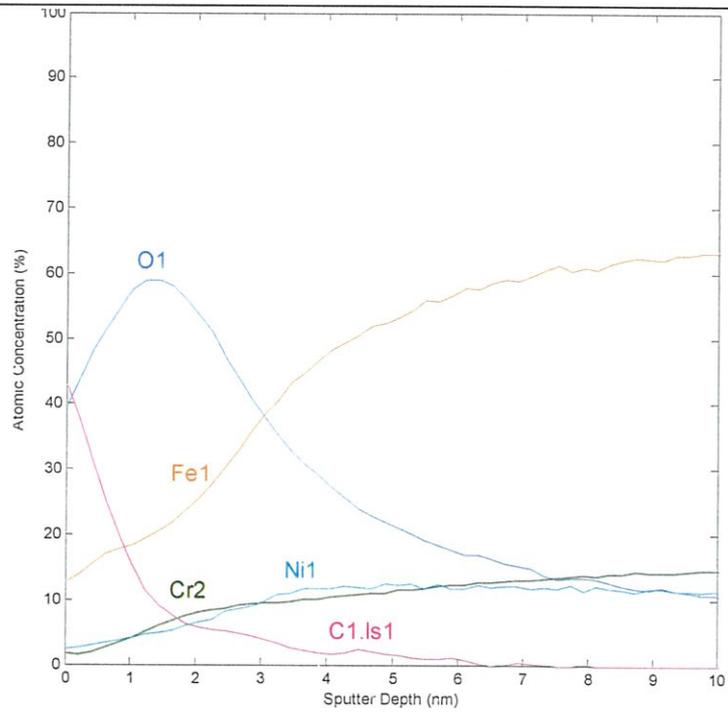
### 3.3 Tabular summary

Item	
maximun Cr/Fe ratio	0.31
Cr/Fe ratio at 10Å*	0.31
Oxide thickness	38.4Å
The corrected thickness of the oxide layer**	30.8Å
Carbon thickness	7.6Å
The thickness of individual iron oxides	/

\*: The test depth is 10 A plus the thickness of layer C.

\*\* : The modification of the oxide layer thickness takes into account the influence of the thickness of the C layer.

### 3.4 Depth profile of Cr,Fe,Ni,O,C



**End of Test Report**